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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Yoshiharu Kirakata et al.      Art Unit : 2811  
Serial No. : 10/656,170      Examiner : David Nhu  
Filed : September 8, 2003      Confirmation No.: 9943  
Title : SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF

**Mail Stop Amendment**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

**AMENDMENT IN REPLY TO ACTION OF JANUARY 26, 2004**

Please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 11 of this paper.

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